Tota	l No.	of Questions : 8] SEAT No. :	\neg
P36	13	[Total No. of Pages	: 2
		[4959]-1099	
		B.E. (E & TC)	
		Nano Electronics and MEMS	
		(2012 Pattern) (Semester - II)	
Time	2:24	[Max. Marks:	7 0
Instr	ructio 1) 2) 3) 4)	ons to the candidates: Answer any one question out of Q.1 or Q.2, Q.3 or Q.4, Q.5 or Q.6, Q.7 or Q Neat diagrams must be drawn wherever necessary. Use of electronic pocket calculator is allowed. Assume suitable data, if necessary.).8.
Q1)	a)	Explain temperature effects in semiconductor.	[7]
	b)	What is Lithography? Write different methods which are used for fabrication.	IC [7]
	c)	What is Fin FET? How it is different than normal FET?	[6]
		OR	
Q2)	a)	What are the different technologies which are used for silicon crys growth?	tal [7]
	b)	What is etching? What do you mean by wet etching and dry etching?	[7]
	c)	Write short notes on:	[6]
		i) Dopant diffusion	
		ii) Sputtering	
Q3)	a)	Discuss three different approaches for circuits that can be integrat with MEMS.	ted [9]
	b)	What is Encapsulation? Explain Importance of it.	[9]
		OR	
Q4)	a)	Explain experimental methods for measuring intrinsic stress.	[9]
	b)	Write a short note on i) Sensor ii) Actuator	[9]

iii)

Transducer

P.T.O.

a)	What is direct and inverse effect of piezo electric sensors?	[8]
b)	Compare electrostatic and thermal actuation methods.	[8]
	OR	
a)	What are the aspects, which should be considered for successful desired of accelerometer.	gn [8]
b)	Write short note on comb drive devices.	[8]
a)	Write short note on	[8]
	i) Profilo meter	
	ii) Reflectometer	
b)	What are the advantages and disadvantages of Transmission Electron Microscopy (TEM) in comparison to Scanning Electron Microsco (SEM).	
	OR	
a)	What is FTIR? Explain advantages, limitations and applications FTIR.	[8]
b)	Write short note on Atomic Force Microscope. (AFM)	[8]
	b) a) b) a) b)	b) Compare electrostatic and thermal actuation methods. OR a) What are the aspects, which should be considered for successful desir of accelerometer. b) Write short note on comb drive devices. a) Write short note on i) Profilo meter ii) Reflectometer b) What are the advantages and disadvantages of Transmission Electric Microscopy (TEM) in comparison to Scanning Electron Microsco (SEM). OR a) What is FTIR? Explain advantages, limitations and applications FTIR.
